

## Application Data Sheet

### Application Information

**Application Type::** Regular  
**Subject Matter::** Utility  
**Suggested classification::**  
**Suggested Group Art Unit::**  
**CD-ROM or CD-R?::** None  
**Computer Readable Form (CRF)?::** No  
**Title::** PLASMA ETCHING APPARATUS WITH  
FOCUS RING AND PLASMA ETCHING  
METHOD  
**Attorney Docket Number::** 025311-0109  
**Request for Early Publication?::** No  
**Request for Non-Publication?::** No  
**Suggested Drawing Figure::** 1  
**Total Drawing Sheets::** 2  
**Small Entity?::** No  
**Petition included?::** No  
**Secrecy Order in Parent Appl.?::** No

### Applicant Information

**Applicant Authority Type::** Inventor  
**Primary Citizenship Country::** Japanese  
**Status::** Full Capacity  
**Given Name::** Osamu  
**Family Name::** KOIKE  
**City of Residence::** Kanagawa  
**Country of Residence::** Japan

**Street of mailing address::**

c/o SEMICONDUCTOR LEADING EDGE  
TECHNOLOGIES, INC.

292 Yoshida-cho, Totsuka-ku

Yokohama, Kanagawa 244-0817

**Country of mailing address::**

Japan

### **Correspondence Information**

**Correspondence Customer Number::** 22428

**E-Mail address::**

wellis@foleylaw.com

### **Representative Information**

<b>Representative Designation::</b>	<b>Registration Number::</b>	<b>Representative Name::</b>
Primary	29,768	STEPHEN A. BENT
Primary	26,257	DAVID A. BLUMENTHAL
Primary	35,087	BETH A. BURROUS
Primary	28,163	ALAN I. CANTOR
Primary	26,874	WILLIAM T. ELLIS
Primary	28,822	JOHN J. FELDHAUS
Primary	32,904	MICHAEL D. KAMINSKI
Primary	34,079	LYLE K. KIMMS
Primary	25,735	KENNETH E. KROSIN
Primary	34,649	JOHNNY A. KUMAR
Primary	19,621	JACK LAHR
Primary	34,371	GLENN LAW
Primary	26,001	PETER G. MACK
Primary	35,264	STEPHEN B. MAEBIUS
Primary	32,789	BRIAN J. MC NAMARA

Primary	35,792	RICHARD C. PEET
Primary	32,792	GEORGE E. QUILLIN
Primary	34,702	ANDREW E. RAWLINS
Primary	28,665	BERNHARD D. SAXE
Primary	27,590	CHARLES F. SCHILL
Primary	25,479	RICHARD L. SCHWAAB
Primary	34,717	MICHELE M. SIMKIN
Primary	25,258	HAROLD C. WEGNER

### Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

### Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2000-372798	12/07/2000	Yes

### Assignee Information

Assignee name::

SEMICONDUCTOR LEADING EDGE  
TECHNOLOGIES, INC.